

**ELECTRONIC SUPPLEMENTARY INFORMATION**

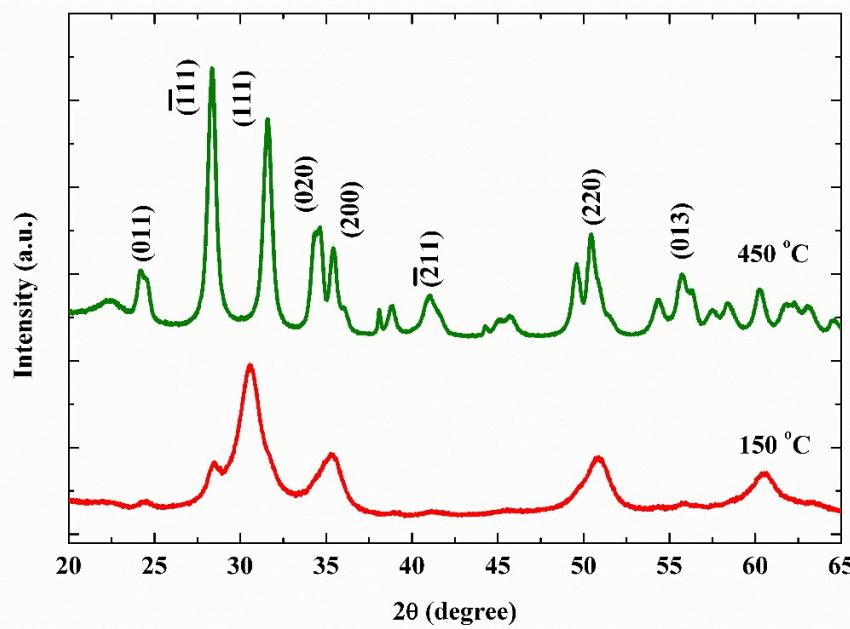
**Blue luminescence and Schottky diode applications of  
monoclinic  $\text{HfO}_2$  nanostructures**

**G. Mohan Kumar<sup>a\*</sup>, P. Ilanchezhiyan<sup>a</sup>, Fu Xiao<sup>a</sup>, C. Siva<sup>b</sup>, A. Madhan Kumar<sup>c</sup>,  
Vadim Yalishev<sup>a</sup>, Sh. U. Yuldashev<sup>a</sup> and T. W. Kang<sup>a</sup>**

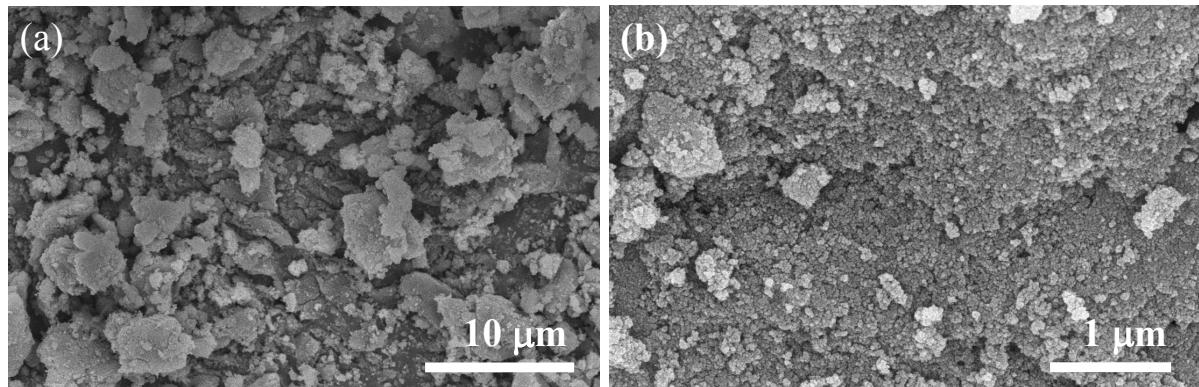
<sup>a</sup>Quantum-Functional Semiconductor Research Center, Dongguk University,  
Seoul, Republic of Korea.

<sup>b</sup>Department of Physics and Nanotechnology, SRM University,  
Kattankulathur, Chennai, India.

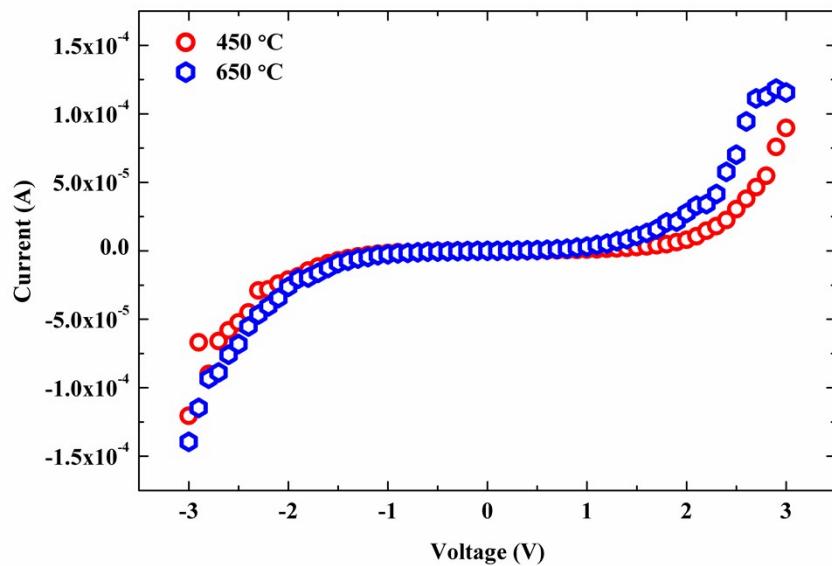
<sup>c</sup>Center of Research Excellence in Corrosion,  
King Fahd University of Petroleum & Minerals, Kingdom of Saudi Arabia  
Fax: +82-2-2278-4519; Tel: +82-10-4896-1777  
Email: selvi1382@gmail.com, gmohankumar@dongguk.edu



**Figure S1:** (a) X-ray diffraction patterns revealing the (a) amorphous and (b) monoclinic phase of  $\text{HfO}_2$  nanostructures while annealed at 150 and 450 °C, respectively.



**Figure S2:** (a, b) Low-magnification SEM images of  $\text{HfO}_2$  nanostructures.



**Figure S3:**  $I$ - $V$  characteristics of  $M\text{-Ag}/i\text{-}\text{HfO}_2/n\text{-Si}$  heterojunctions fabricated using 450 and 650 °C annealed  $\text{HfO}_2$  nanostructures.

**Parameters obtained through fitting the Nyquist plot shown in Fig. 4b:**

Charge transfer resistance ( $R_{ct}$ )	: 986 k $\Omega$ cm $^2$
Primary layer resistance ( $R_f$ )	: 25 k $\Omega$ cm $^2$
Constant phase element of primary layer capacitance ( $C_f$ )	: 1.218 $\mu\text{F cm}^2$
Constant 1 ( $n_f$ )	: 0.98
Constant phase element of double layer capacitance ( $C_{dl}$ )	: 24.64 $\mu\text{F cm}^2$
Constant 2 ( $n_{dl}$ )	: 0.97